

Notice of References Cited	Application/Control No. 09/670,399	Applicant(s)/Patent Under Reexamination WASHIZU ET AL.	
	Examiner Jennine M. Brown	Art Unit 1755	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,814,200 A	09-1998	Pethig et al.	204/547
*	B	US-5,948,328 A	09-1999	Fiedler et al.	264/5
*	C	US-6,149,789 A	11-2000	Benecke et al.	204/547
*	D	US-5,653,859 A	08-1997	Parton et al.	204/450
*	E	US-6,875,329 B2	04-2005	Washizu et al.	204/547
*	F	US-5,344,535 A	09-1994	Betts et al.	204/547
*	G	US-4,970,154 A	11-1990	Chang, Donald C.	424/93.21
*	H	US-6,294,063 B1	09-2001	Becker et al.	204/450
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Washizu and Kurosawa, "Electrostatic Manipulation of DNA in Microfabricated Structures", IEEE Transactions on Industry Applications, Vol. 26, No. 6, November/December 1990.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.